

## About ICXRL 2020

The ICXRL was established as a biannual event to promote the development of advanced extreme UV and X-ray sources, and their scientific applications in various fields. Joining ICXRL means experiencing the latest trends and shaping the future progress. Latest results involving state-of-the-art X-ray sources generated from intense lasers, plasmas or accelerated particles will be presented. Lecturers are expected to submit a paper for the Proceedings volume, which will be published by SPIE.

The program includes keynote lectures, invited lectures, technology focus talks and contributed short talks.

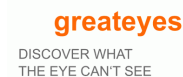
**The Deadline** for abstract submission for a contributed short talk or a poster is **October 11<sup>th</sup>, 2020**.

## Contacts

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Chair of the ICXRL20  
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## Partners & Supporters



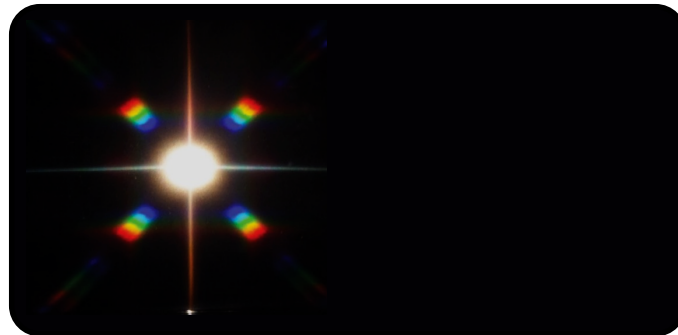
[scg.ch/icxrl/2020](http://scg.ch/icxrl/2020)

Swiss Chemical Society

## 17. International Conference on X-Ray Lasers 2020

Online Conference

December 08.-10, 2020,  
Host: Empa Dübendorf, Switzerland



SCS  
Swiss Chemical Society

## Keynote Speakers (tutorials & reviews)

- Igor Artyukov, Lebedev Institute, Moscow
- Davide Bleiner, Empa Dübendorf
- Sergej Bulanov, ELI Dolni Brezany
- Tetsuya Kawachi, KPSI Kyoto
- Annie Klisnick, CNRS Paris
- Olga Kocharovskaya, TAMU, College Station
- Joe Nilsen, LLNL Livermore
- Jorge J. Rocca, CSU Fort Collins
- Stephane Sebban, LOA Paris
- Szymon Suckewer, Princeton University
- Holger Stiel, MBI Berlin
- Greg Tallents, University of York

## Confirmed Invited Speakers

- Sasa Bajt, DESY Hamburg
- Henry Chapman, DESY Hamburg
- Paul Corkum, University of Ottawa
- Hans Hertz, KTH Stockholm
- Thomas Lippert, PSI Villigen
- Mikako Makita, EuroFEL Schenefeld
- Jaroslav Nejdil, ELI Dolni Brezany
- Elke Plönjes-Palm, FLASH Hamburg
- Jeroen van Tilborg, LBNL Berkeley
- Hans-Jakob Wörner, ETH Zurich

## Technology Focus Talks

- Greateyes, Axel Wiegand
- Luxel, Travis Ayes
- Applied NT, Rob Peters
- Rigaku, Ladislav Pina
- XUV Lasers, Carmen Menoni

Group Picture from the ICXRL 2018 in Prague, Czech Republic



## Registration Fees

- Free admission for SCS members, students, keynote speakers and invited guests. However, online registration until start of the conference is mandatory.
- CHF 120.00 for Regular Participants

Please register on [scg.ch/icxrl/2020](http://scg.ch/icxrl/2020)

## Contributed Short Talks and Posters

- If you are interested in presenting your project, please submit an abstract during the registration process.
- The abstract template is available as Word file on the website.
- Deadline for abstract submission is October 11<sup>th</sup>, 2020.
- Deadline for Paper submission (pee-reviewed) is January 4<sup>th</sup>, 2021.

## Pierre Jaeglé Awards 2020

The awards were established to honor Prof. Pierre Jaeglé, one of the X-ray laser pioneers and founder of the conference (ICXRL). The three prizes for the best student presentations are sponsored by SPIE, Elettra Sincrotrone and EXSA.

Group Picture from the ICXRL 2016 in Nara-city, Japan

